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TITLE

## United States Patent and Trademark Office COMMISSIONER FOR PATENTS UNITED STATES PATENT AND TRADEMARK OFFICE WASHINGTON, D.C. 2023 **CONFIRMATION NO. 8779** Rib Data Sheet **FILING DATE ATTORNEY GROUP ART UNIT** CLASS **SERIAL NUMBER** DOCKET NO. D6727/2001 09/891,511 2812 438 010819 RULE **APPLICANTS** Mamoru Nakasuji, Kanagawa, JAPAN; Nobuharu Noji, Kanagawa, JAPAN; Tohru Satake, Kanagawa, JAPAN; Masahiro Hatakeyama, Kanagawa, JAPAN; Toshifumi Kimba, Kanagawa, JAPAN; Hirosi Sobukawa, Kanagawa, JAPAN; Shoji Yoshikawa, Tokyo, JAPAN; Takeshi Murakami, Tokyo, JAPAN; Kenji Watanabe, Kanagawa, JAPAN; Tsutomu Karimata, Kanagawa, JAPAN; Shin Oowada, Kanagawa, JAPAN; Mutsumi Saito, Kanagawa, JAPAN; Yuichiro Yamazaki, Tokyo, JAPAN; Takamitsu Nagai, Kanagawa, JAPAN; Ichirota Nagahama, Kanagawa, JAPAN; CONTINUING DATA BEST AVAILABLE COP/ JAPAN 2000-193104 06/27/2000 JAPAN 2000-229101 07/28/2000 JAPAN 2000-335934 11/02/2000 JAPAN 2001-11218 01/19/2001 JAPAN 2001-31901 02/08/2001 JAPAN 2001-31906 02/08/2001 JAPAN 2001-33599 02/09/2001 JAPAN 2001-35069 02/13/2001 JAPAN 2001-158662 05/28/2001 JAPAN 2001-162041 05/30/2001 JAPAN 2001-189304 06/22/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* 08/29/2001 W/es D no Foreign Priority claimed INDEPENDENT SHEETS TOTAL STATE OR yes on o Met after 35 USC 119 (a-d) conditions **CLAIMS** COUNTRY DRAWING **CLAIMS** met **JAPAN** 50 60 Verified and Acknowledged ADDRESS 23850

Inspection system by charged particle beam and method of manufacturing devices using the system



